

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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08-23-01
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In re application of:

Jong-Hwan CHA, *et al.*

Art Unit: To be assigned

Application No.: To be assigned

Examiner: To be assigned

Filed: Herewith

Atty. Docket: 06192.0094.DVUS01

For: **APPARATUS FOR MANUFACTURING
A THIN FILM TRANSISTOR ARRAY
PANEL FOR A LIQUID CRYSTAL
DISPLAY (AS AMENDED)**

Preliminary Amendment

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Please amend the above-identified patent application as follows.

Amendments

In the Title:

Please amend the title to read: -- Apparatus for Manufacturing a Thin Film Transistor
Array Panel For a Liquid Crystal Display --.

In the Claims:

Please cancel claims 1-9 and add new claim 10 as follows:

10. (New) An apparatus for depositing a layer on a substrate, comprising:
a loadlock chamber that receives a substrate;
a preheat chamber that heats the substrate before deposition;

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